



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

10/22/02  
H6/Amott  
B

Group Art Unit: 1756  
Examiner: Kathleen Duda

RECEIVED

OCT 21 2002

TC 1700

In Re PATENT APPLICATION Of:

Applicant(s) : Minoru WATANABE

Serial No. : 10/025,783

Filed : December 26, 2001

For : METHOD AND APPARATUS FOR  
FORMING RESIST PATTERN

Attorney Ref. : MAE 223 C1

AMENDMENT

October 16, 2002

Commissioner of Patents  
Washington, D.C. 20231  
**Box - Non-Final Office Action**

Sir:

This Amendment is filed in response to the Official Action dated May 22, 2002, the time for response to which is extended up to and including October 22, 2002, by the Petition for Extension of Time submitted herewith. Please amend the above referenced application as follows:

IN THE CLAIMS:

✓  
Please cancel claims 14, 27 and 30

REMARKS

The Examiner's action mailed on May 22, 2002 has been received and its contents carefully considered.

FEE ENCLOSED: \$570,  
Please charge any further  
fee to our Deposit Account  
No. 18-0002